



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT
8733.154.00

#11

Application of:

Jin JANG et al.

Group Art Unit: 1765

Application No.: 09/350,313

Examiner: R. Kunemund

Filing Date: July 9, 1999

For: Method of Crystallizing Amorphous Silicon Layer and
Crystallizing Apparatus Thereof

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. § 1.136

RECEIVED

NOV 26 2001

TC 1700

Commissioner for Patents
Washington, D.C. 20231

Sir:

It is hereby requested that a two month extension of time be granted to **November 17, 2001** for

- ☐ a response to the Office Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☒ filing a Notice of Appeal.
 - ☒ A one month extension of time was previously submitted on: **August 20, 2001.**
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:

The required fee of \$1,130 (\$320 for the NOA and \$810 for the EOT) is enclosed herewith and any further charges may be made against the Attorney of Record's Deposit Account No. 50-0911. A duplicate copy of this sheet is enclosed.

Void date: 11/19/2001 BNGUYEN1
11/19/2001 BNGUYEN1 00000021 09350131
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02-FC:117 -810.00 OP

11/19/2001 BNGUYEN1 00000027 09350313
01 FC:117 810.00 OP

Respectfully submitted,

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By

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Date: November 16, 2001